



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Confirmation No.: 9324

Applicants : Takehiko FUJITA, et al.  
U.S. Serial No. : 10/532,878  
Filed : April 28, 2005  
Examiner : Ram N. Kackar  
Group Art Unit : 1763  
For : THERMAL PROCESSING UNIT AND  
THERMAL PROCESSING METHOD

**AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Office Action mailed on July 12, 2007, please amend the above-identified application as set forth below and consider the following remarks.